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Atty. Docket No.: 0932/00381

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#3

In re the Patent Application of

Ivan Berry et al.

Serial No. 09/505,695

Filed: February 17, 2000

Title: Method of Photoresist Ash Residue Removal



Group Art Unit: Not Yet Assigned

Examiner: Not Yet Assigned

STATUS REQUEST

Commissioner of Patents
Washington, D.C. 20231

Sir:

Please advise the undersigned attorney of the status of the subject patent application.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Martin Abramson", written over a horizontal line.

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